

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Daniel Stearns et al.

Attorney Docket: CIL-10843

Serial No. : 09/896,722

Art Unit: 1765

Filed : June 29, 2001

Examiner: R. Kunemund

For : A Method To Repair Localized Amplitude
Defects In A EUV Lithography Mask Blank

APPLICATION FOR
CHANGE IN CORRESPONDENCE ADDRESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please change the Correspondence Address for the above-identified

application to:

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If you have any questions, please contact the undersigned at 808-875-0012.

Respectfully submitted,



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Dated: September 27, 2004